

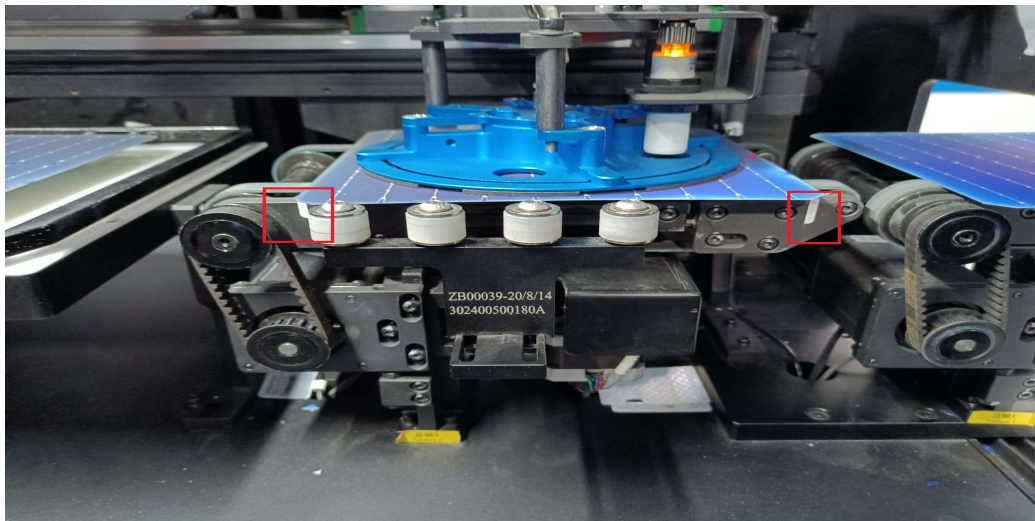
Purpose : To know the steps of adjustment of cell position in Incell camera and between probe area.

Scope : This procedure covers the all steps and parameter after adjustment in tester area for 182 mm wafer.

Responsibility : HOD Maintenance

Procedure:

- Make sure the cell is placed between the marked area in 2nd transport.



- If any issue comes like: Camera taking timeout need to check the In splint parameter which is set according to 182mm. Below 2 nos. pictures are for reference.

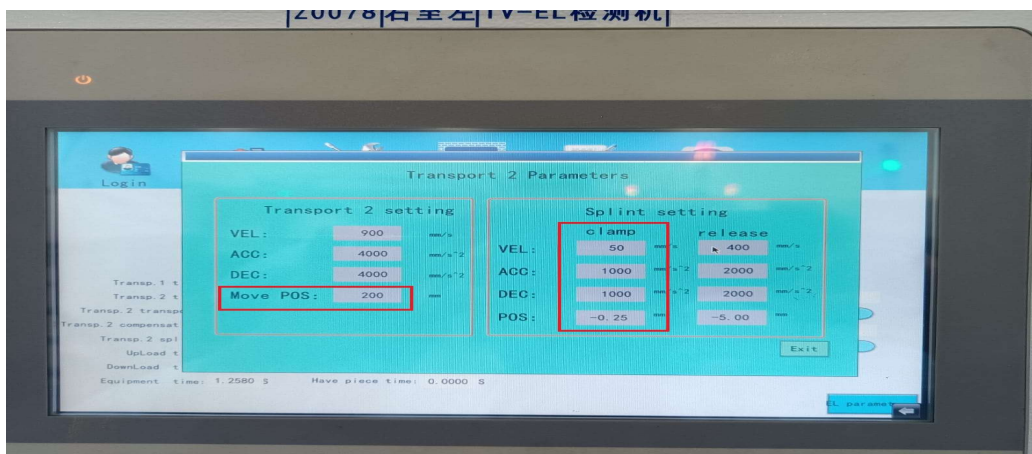


Figure 1

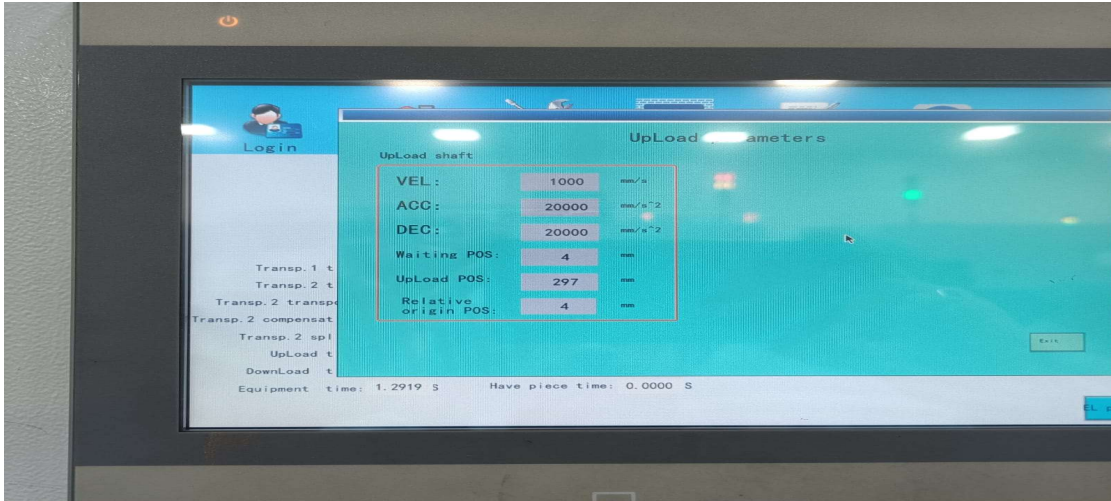
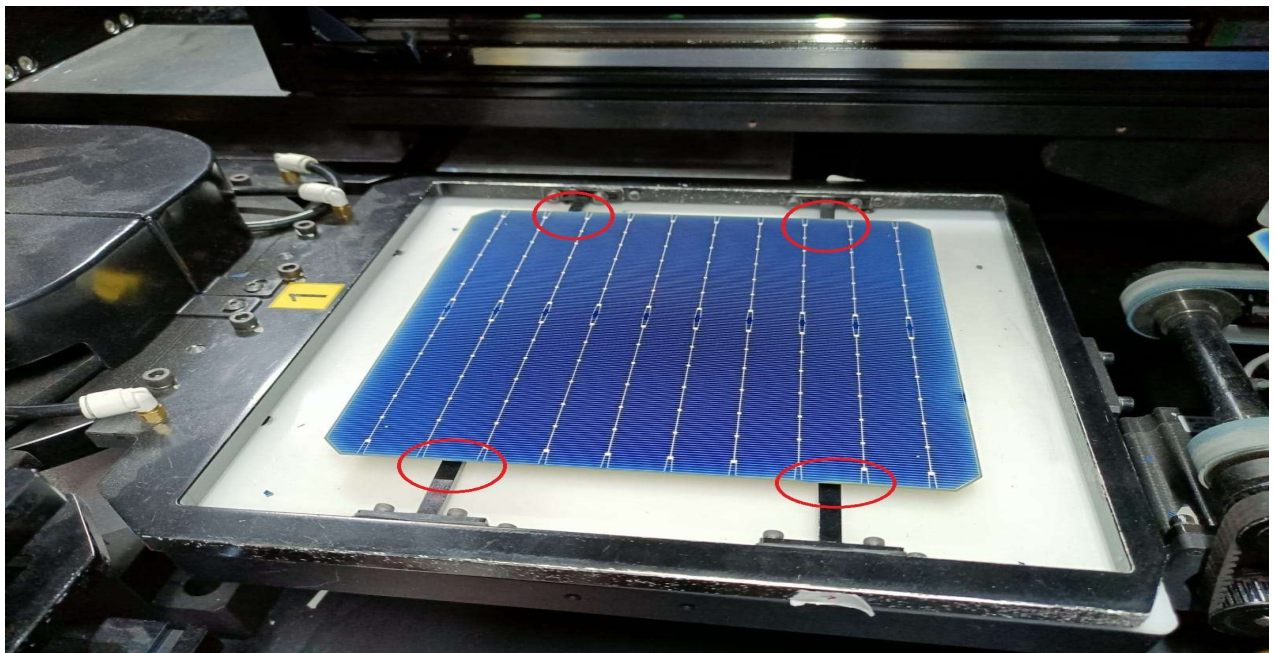
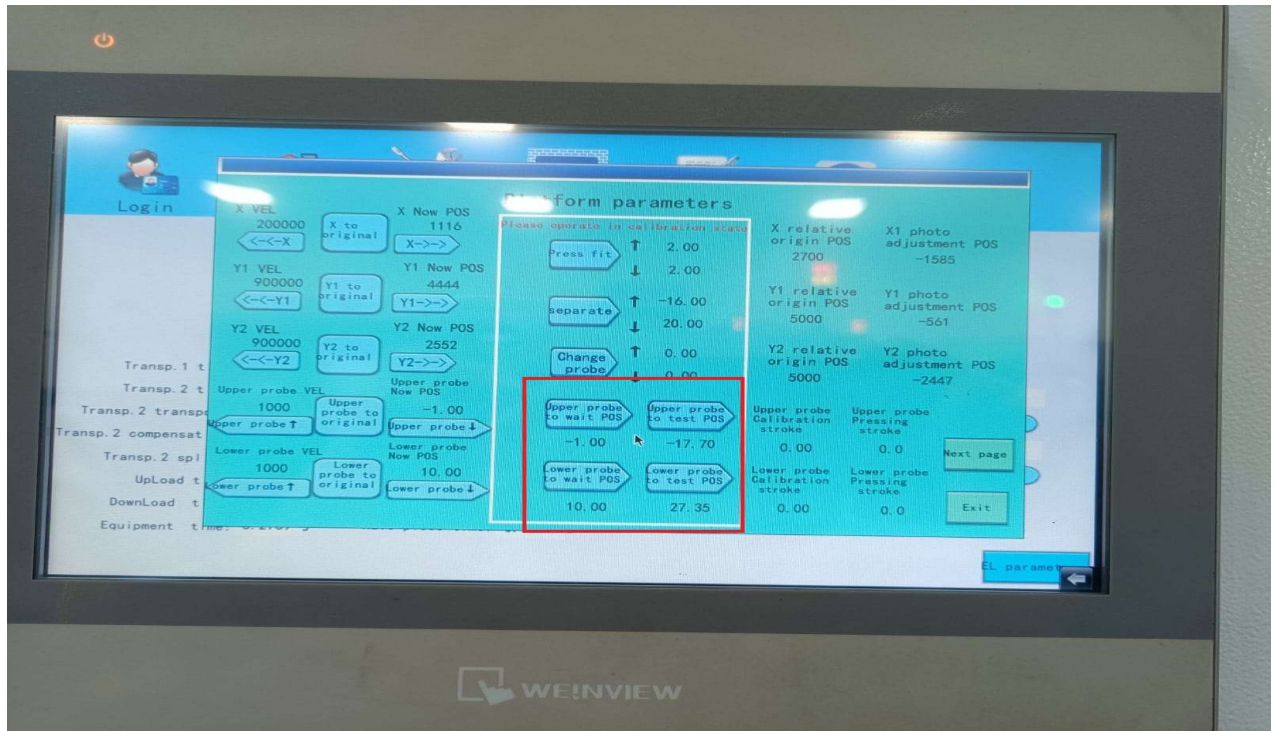


Figure 2

- **Figure 1** is for splint parameter and **figure 2** is for upload parameter.
- To change all those parameter have to log in with proper authorozation.
- Next step is to check the cell position on rotary table. Cell should be in center of the table. As shown in **Red** marked area.





- Next step in probe setting for up and down unit. After change the probe pressing setting EL image need to check with process person. Here reference picture given of basic probe parameter .



- Rotary table vaccume cup is mandatory to check if observe any perticular table breakage occureing.



- If above all conditions are ok, still wafer placement issue arise need to check the in camera basic setting.
- After login with proper authorization.
- Select **Login**  Click **Debug**  Click **Configparam** if parameter change Click **save** then Exit the interface after saving.

